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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Tak Kin Chu, et. al.

Serial No.: 09/853,925

Group Art Unit: N/A

Filed: May 9, 2001

Examiner: Thanh Nguyen

For: ELECTRONIC DEVICES WITH DIFFUSION BARRIER AND PROCESS
FOR MAKING SAMEAMENDMENTCommissioner for Patents and Trademarks
Washington, D.C. 20231

Sir:

Responsive to telephone conferences with Examiner
Nguyen, the following amendments and remarks are
respectfully submitted in connection with the above
identified application.

In the Claims:

Amend claims 15, 16, 17, 18, 20, 22, 23, 24, 25, 26,
27 and 28 to depend on new claim 29.

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15. (Amended) A process for making a semiconductor
device according to claim 29, wherein the forming of the
barrier film comprises the following substeps:
vapor depositing a metal halide on the cleaned heated